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Nanostructured Photovoltaic Devices

Guest Editor:

Dr. Ruxandra Vidu

1. Electrical Engineering and
Computer Science, University of
California Davis, Davis, CA 95616,
USA

2. Faculty of Material Sciences
and Engineering, Politehnica
University of Bucharest, 060042
Bucharest, Romania

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Message from the Guest Editor

Nanostructured photovoltaics have already proven rapid developments and are marked to revolutionize our everyday life. The exciting developments in the field of the light trapping features of nanostructures and solar cell nano-engineered architecture present challenges with unique opportunities to explore new ideas regarding nanostructure integration into photovoltaics.

In this Special Issue of *Micromachines* we invite contributions on the latest developments on nanostructured photovoltaics with improved efficiency from all types of solar cells employing nanostructures, low dimensionality features and emerging technologies in nano-integration. We would like to open the discussions for future directions and challenges in the development of nanostructured photovoltaic devices.



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Editor-in-Chief

Prof. Dr. Ai-Qun Liu

1. Department of Electrical and Electronic Engineering, The Hong Kong Polytechnic University, Hong Kong, China
2. School of Electrical and Electronic Engineering, Nanyang Technological University, Singapore 639798, Singapore

Message from the Editor-in-Chief

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Micromachines Editorial Office
MDPI, Grosspeteranlage 5
4052 Basel, Switzerland

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